## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

Kazuhiko ODA et al.

Group Art Unit: 1751

Application No.:

10/803,880

Examiner: K. VIJAYAKUMAR

Filed: March 19, 2004

Docket No.: 119168

For:

MANUFACTURING PROCESS OF CONDUCTIVE COMPOSITION AND A

MANUFACTURING PROCESS OF CONDUCTIVE PASTE

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- $\boxtimes$ This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. The reference was cited in a counterpart foreign application.
- 冈 3. A English language Abstract of the non-English language reference is attached hereto.
- 冈 4. A computer-generated English language translation of the following Japanese Patent Publication has been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy. See Reference 1.

Respectfully submitted,

James A. Oliff

Registration No. 27,075

Linda M. Saltiel

Registration No. 51,122

JAO:LMS/cdt

Date: January 24, 2006

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE **AUTHORIZATION** Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461

Sheet 1 of 1

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 119168				APPLICATION NO. 10/803,880			
INFORMATION DISCLOSURE STATEMENT									•		
(Use several sheets if necessary)				APPLICANT(S) Kazuhiko ODA et al.							
					OATE , 2004	GROUP . 1751					
		U.S. P	ATEN	NT DOCU	MENTS					_	
EXAMINER INITIAL		DOCUMENT NUMBER	D	ATE NAME			3		CLASS	SUB CLASS	
	ļ										
					•		_				
			•								
FOREIGN PATENT DOCUMENTS											
		DOCUMENT NUMBER	D.	АТЕ		COUNTRY			CLASS	SUB CLASS	
	1	JP A 2002-245874	08-30	-2002	JAPAN						
							·				
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)											
			****								
							-				
EXAMINER							DATE CO	ONSID	ERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.											
		comornance and not considered. Include copy of this form with next communication to applicant.									